

2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213

T 202.293.7060
F 202.293.7860

www.sughrue.com

Sughrue

SUGHRUE MION, PLLC

December 21, 2001

BOX PATENT APPLICATION

Commissioner for Patents

Washington, D.C. 20231

Re: Application of Kouji FUNAKI, Katsura MATSUBARA, Hiroki WATANABE,
and Masaya ITO
SILICON NITRIDE SINTERED MATERIAL AND PRODUCTION PROCESS
THEREOF
Assignee: NGK SPARK PLUG CO., LTD.
Our Ref. Q67798

Dear Sir:

Attached hereto is the application identified above comprising 25 sheets of the
specification, including the claims and abstract, and 1 sheet of drawings. The executed
Assignment and Declaration and Power of Attorney will be submitted at a later date.

The Government filing fee is calculated as follows:

Total claims	6 - 20	=		x	\$18.00	=	\$0.00
Independent claims	2 - 3	=		x	\$84.00	=	\$0.00
Base Fee							\$740.00

TOTAL FILING FEE

\$740.00

A check for the statutory filing fee of \$740.00 is attached. You are also directed and
authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880.
The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and
any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the
entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this
transmittal letter is attached.



Sughrue

SUGHRUE MION, PLLC

Priority is claimed from:

Country

Application No

Filing Date

Japan

2000-402257

December 28, 2000

The priority document will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By: _____

Abraham J. Rosner

Registration No. 33,276

100405 4200
"STREET" 0000